



501.41175X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): NAKANO, et al
Serial No.: 10/075,244
Filed: February 15, 2002
For: METHOD AND APPARATUS FOR PLASMA PROCESSING
Group: 1762
Examiner: M. Padgett

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 5, 2004

Sir:

In response to the Office Action dated November 5, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.